



"RESPONSE UNDER 37 CFR 1.116-
EXPEDITED PROCEDURE EXAMINING
GROUP 2135"



Docket No.: 203058US2RD

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

ATTORNEYS AT LAW

RE: Application Serial No.: 09/781,284
Applicants: Mikio HASHIMOTO, et al.
Filing Date: February 13, 2001
For: METHOD AND SYSTEM FOR DISTRIBUTING
PROGRAMS USING TAMPER RESISTANT
PROCESSOR
Group Art Unit: 2135
Examiner: SON, LINH L.D.

SIR:

Attached hereto for filing are the following papers:

Request for Reconsideration under 37 CFR §1.116

Our check in the amount of 0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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EXPEDITED PROCEDURE EXAMINING
GROUP 2135"

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

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IN RE APPLICATION OF :
MIKIO HASHIMOTO, ET AL. : EXAMINER: SON, LINH, L.D.
SERIAL NO: 09/781,284 :
FILED: FEBRUARY 13, 2001 : GROUP ART UNIT: 2135
FOR: METHOD AND SYSTEM FOR :
DISTRIBUTING PROGRAMS USING
TAMPER RESISTANT PROCESSOR

REQUEST FOR RECONSIDERATION UNDER 37 CFR §1.116

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated April 22, 2005, please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.